

Search Notes

Application/Control No.

10/532,430

Examiner

Steven D. Maki

Applicant(s)/Patent under
Reexamination

YAMANE, KENJI

Art Unit

1791

SEARCHED

Class	Subclass	Date	Examiner
152	209.21		
	209.22		
updated	above	1/5/2008	<i>Sm</i>

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
none	1/5/2008	<i>Sm</i>